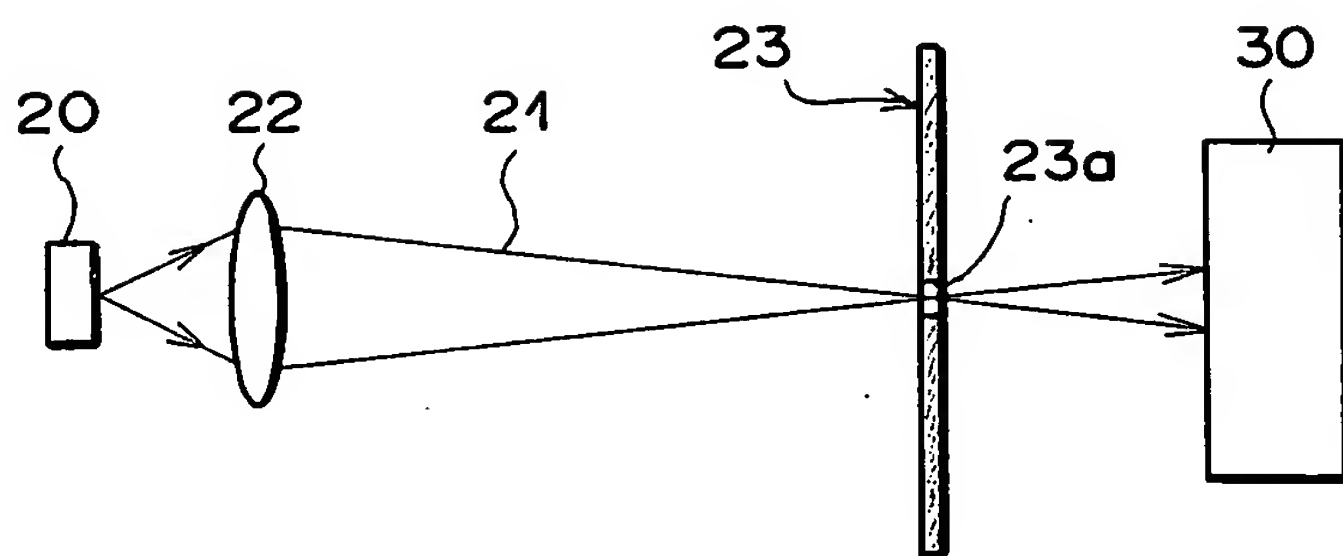
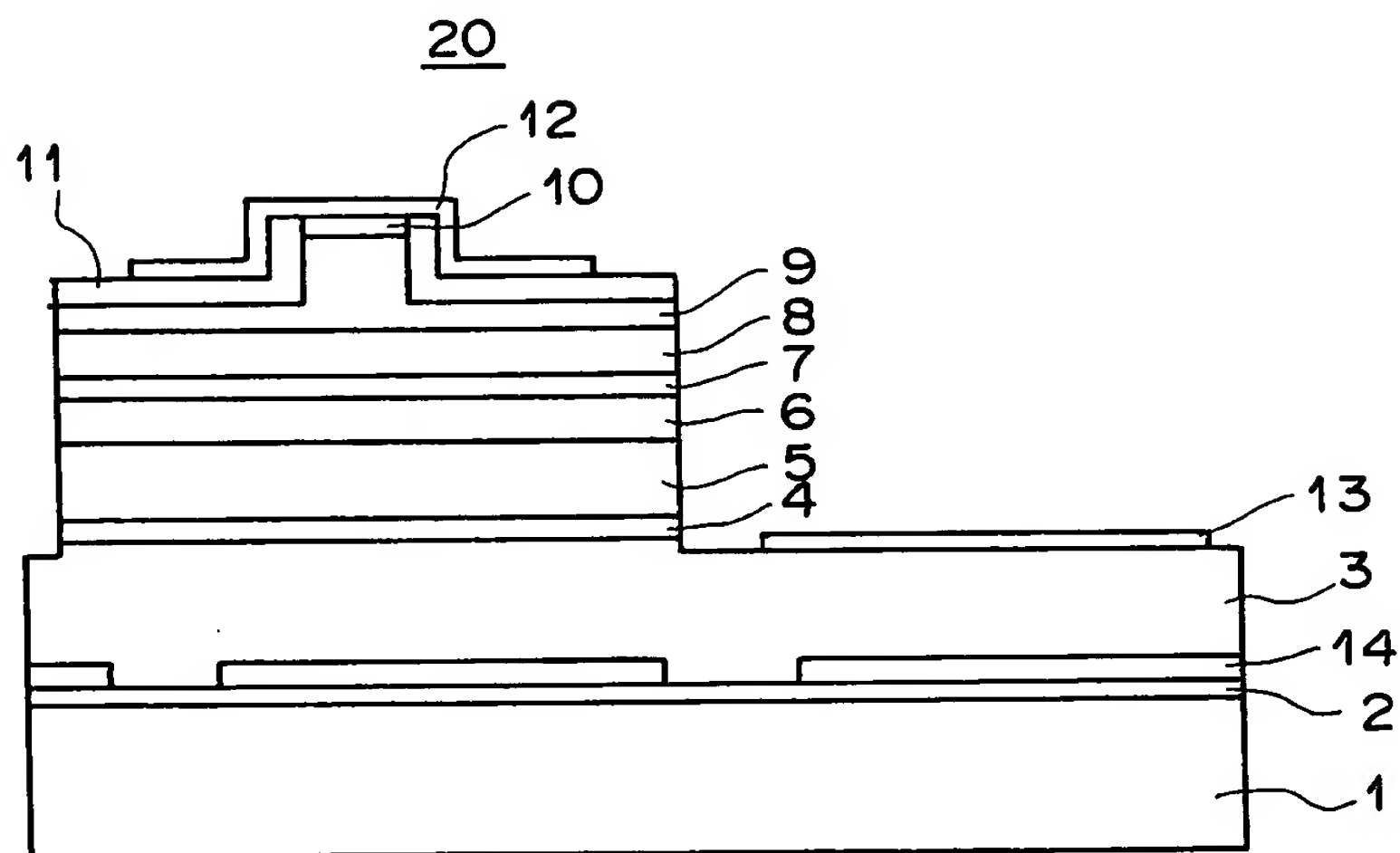


FIG. 1

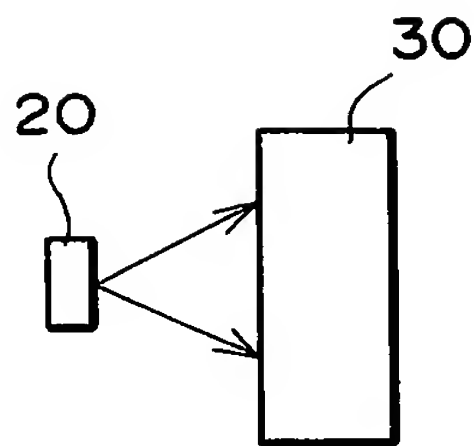


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F I G . 2



F I G . 3



F I G . 4

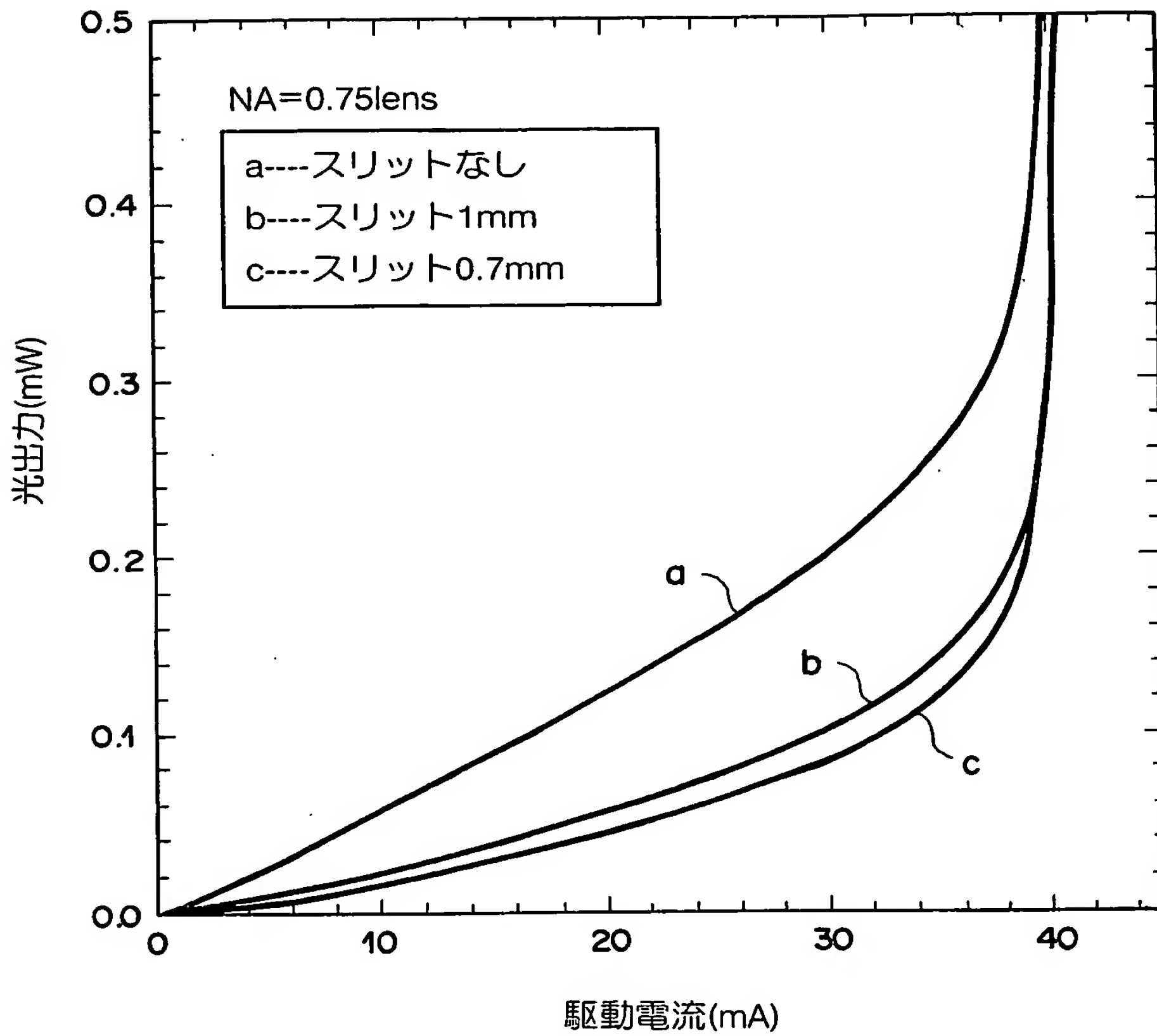
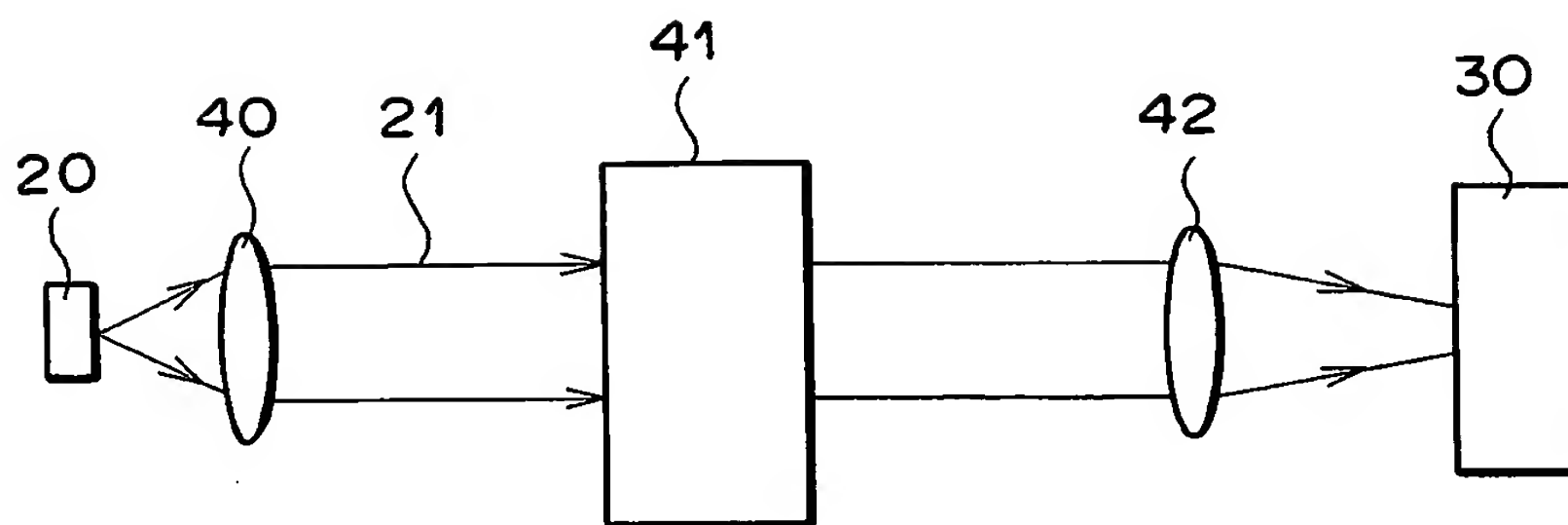
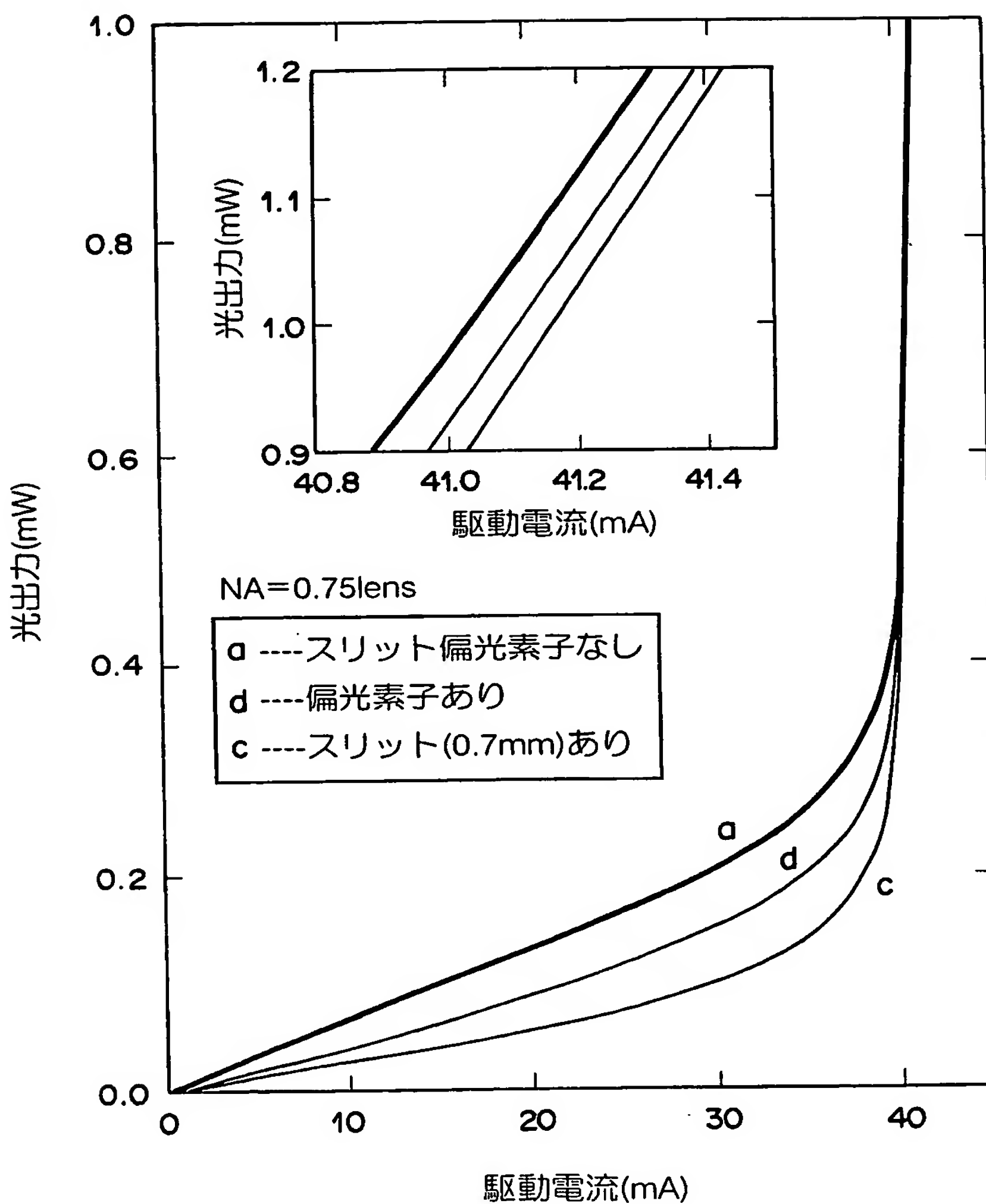


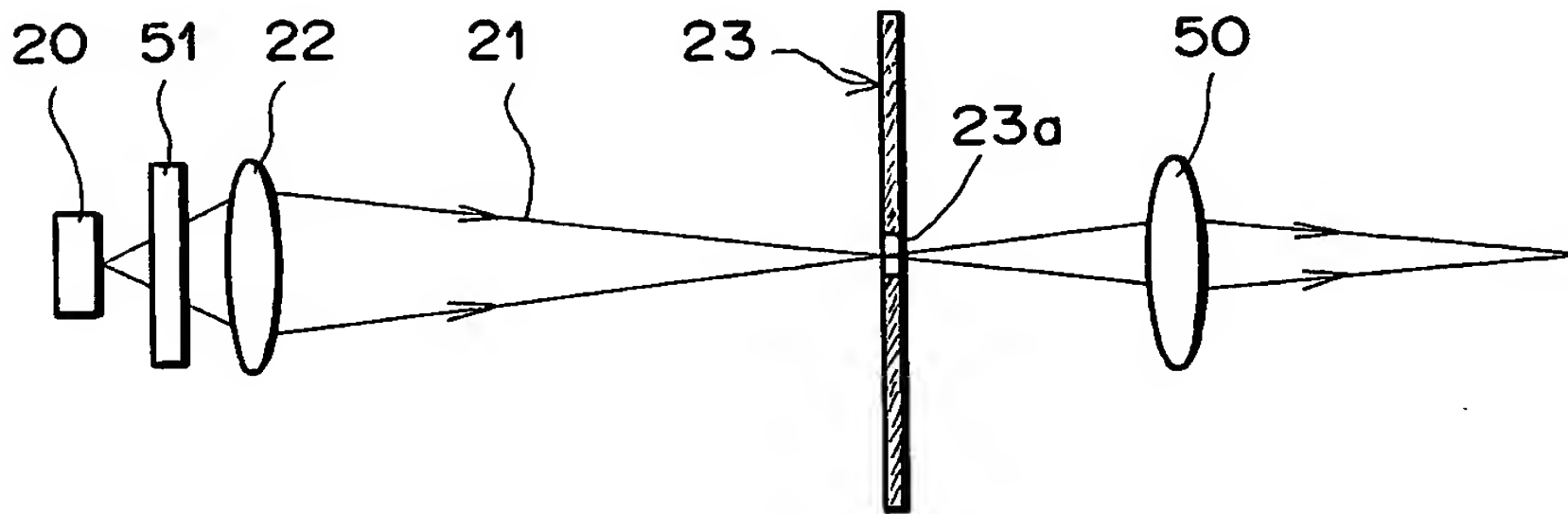
FIG. 5



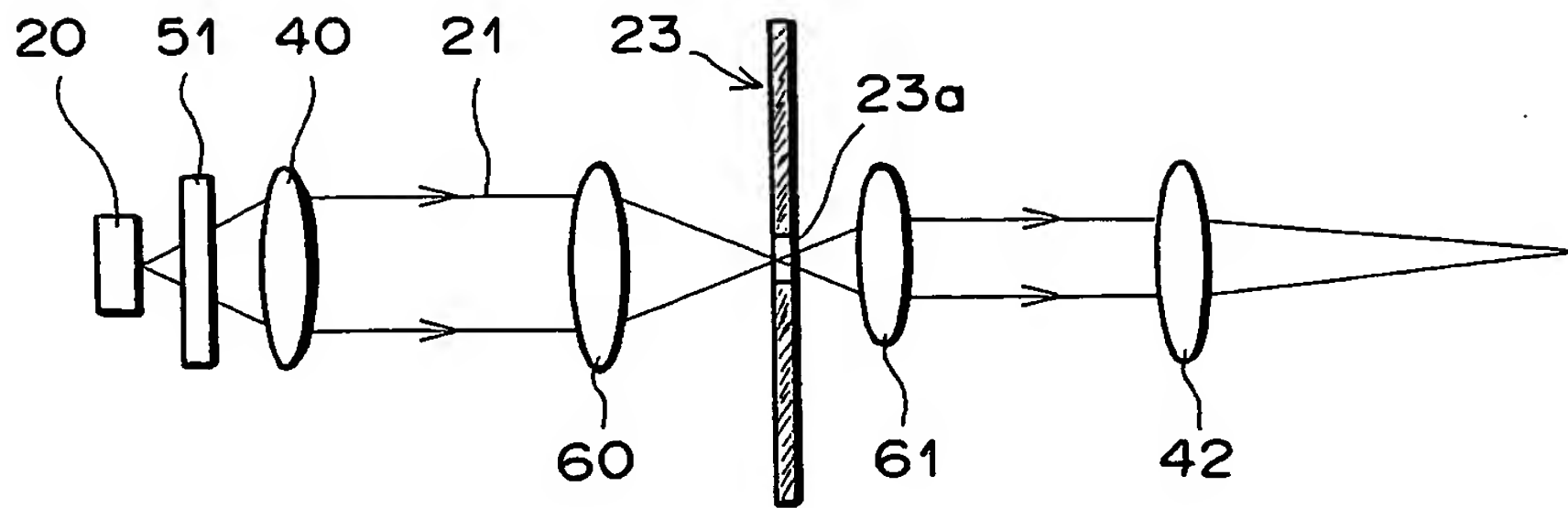
F I G . 6



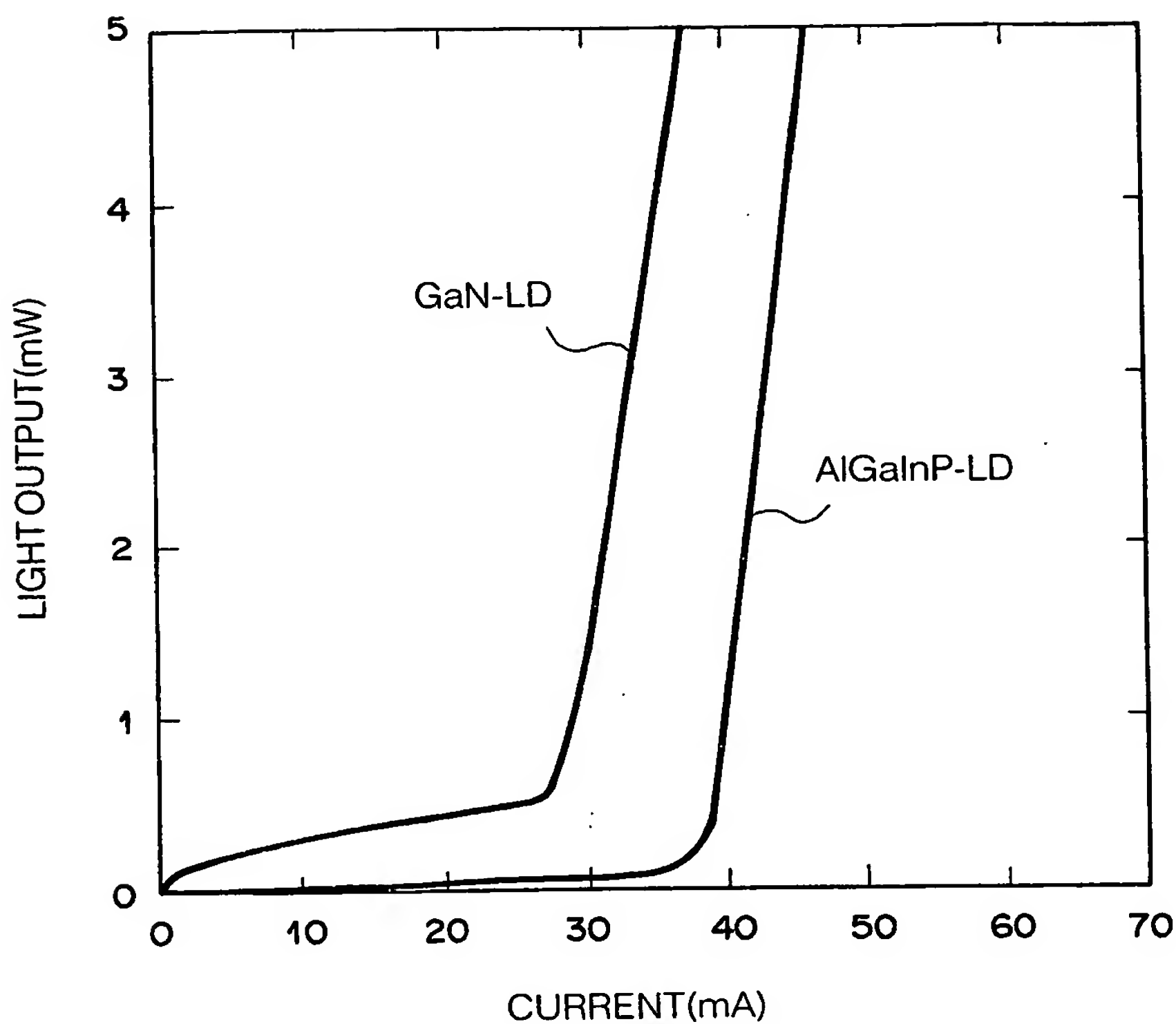
F I G . 7



F I G . 8



F I G . 9



F I G . 10

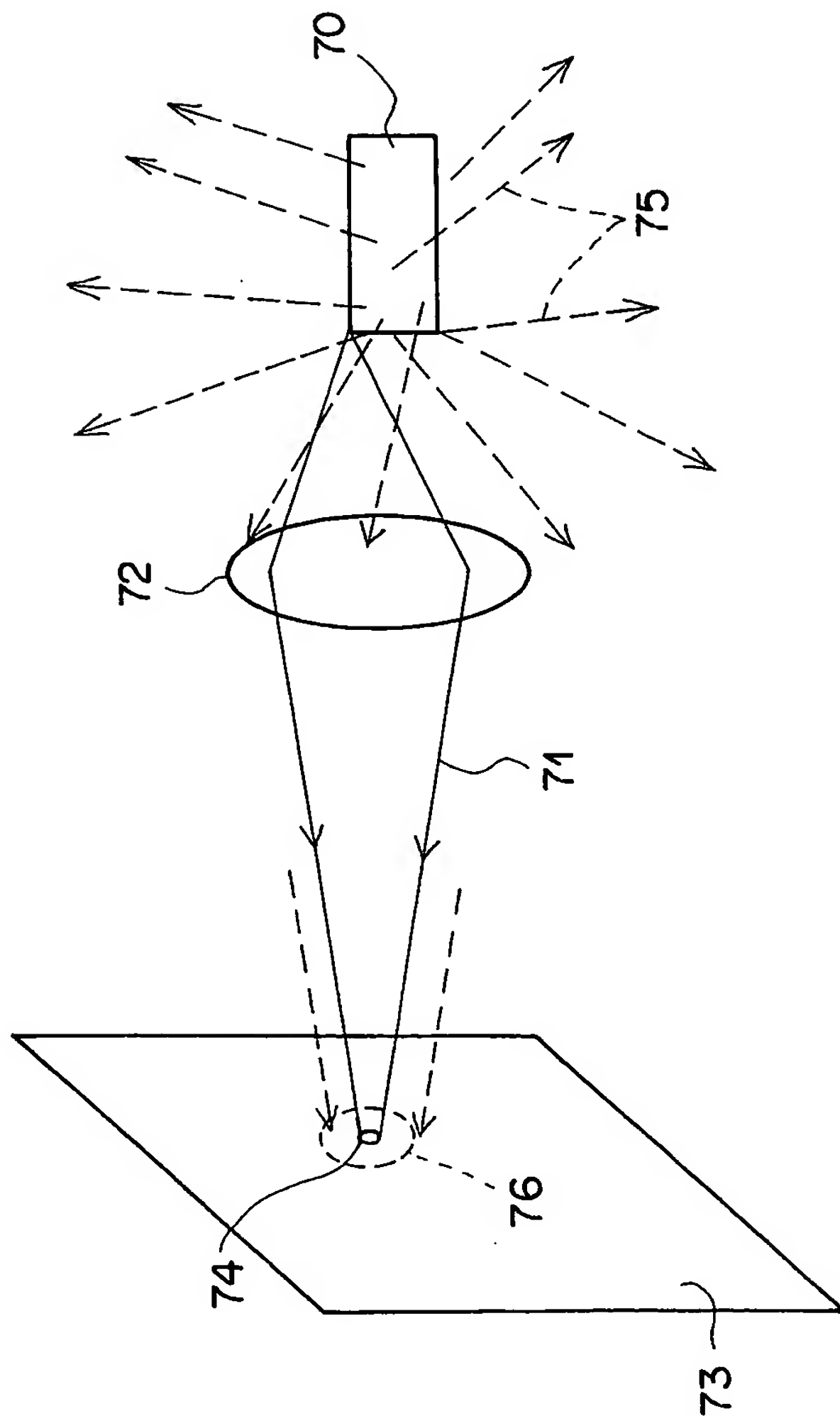


FIG. 11

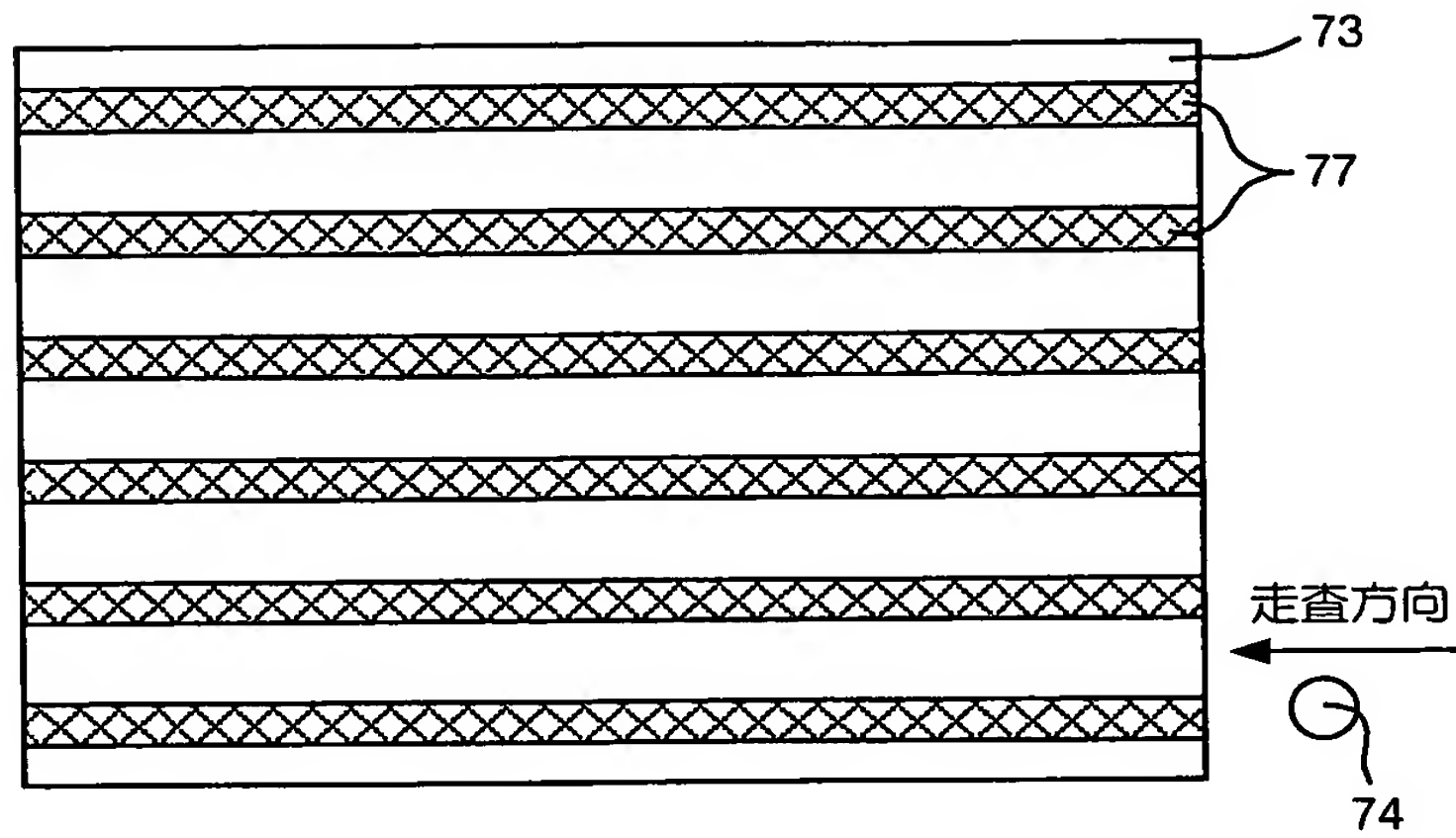
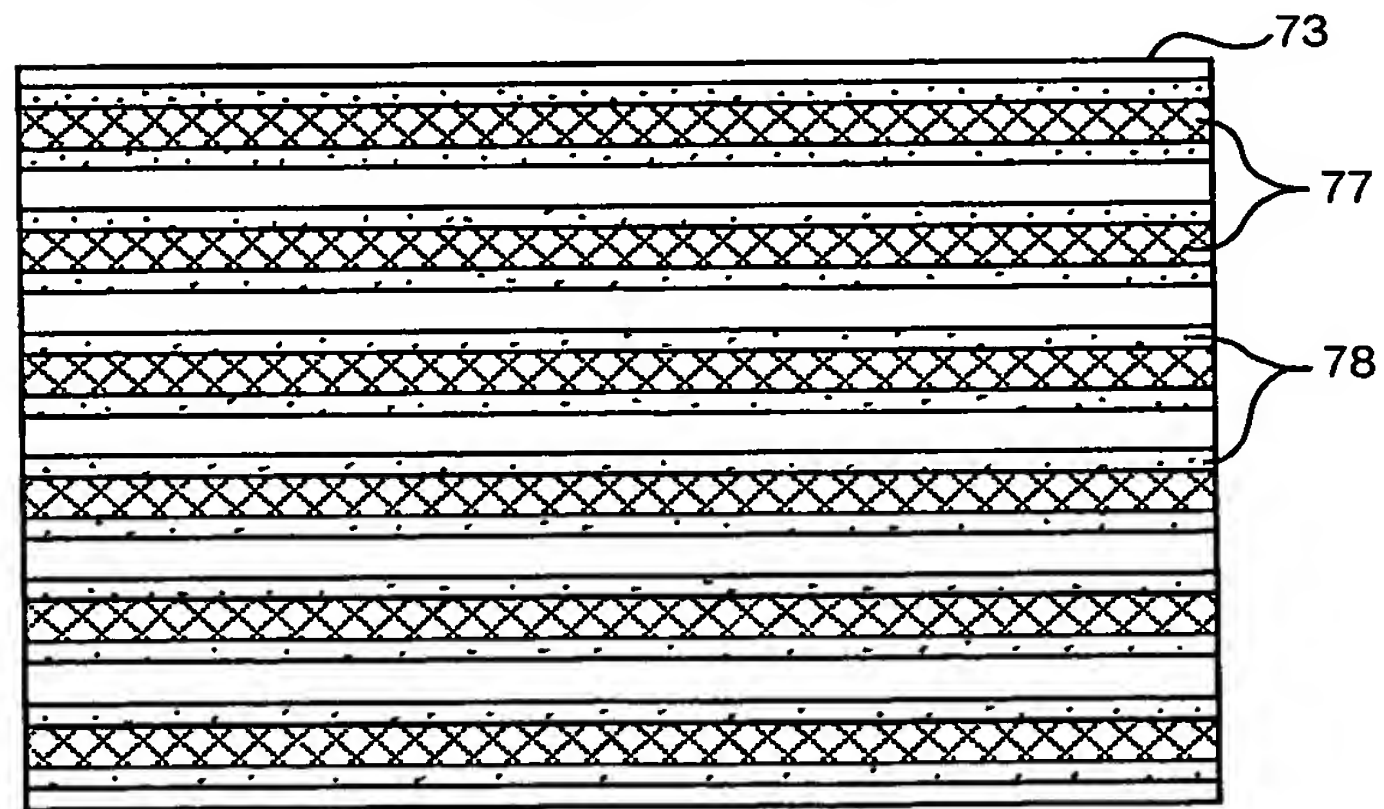


FIG. 12



F I G .13

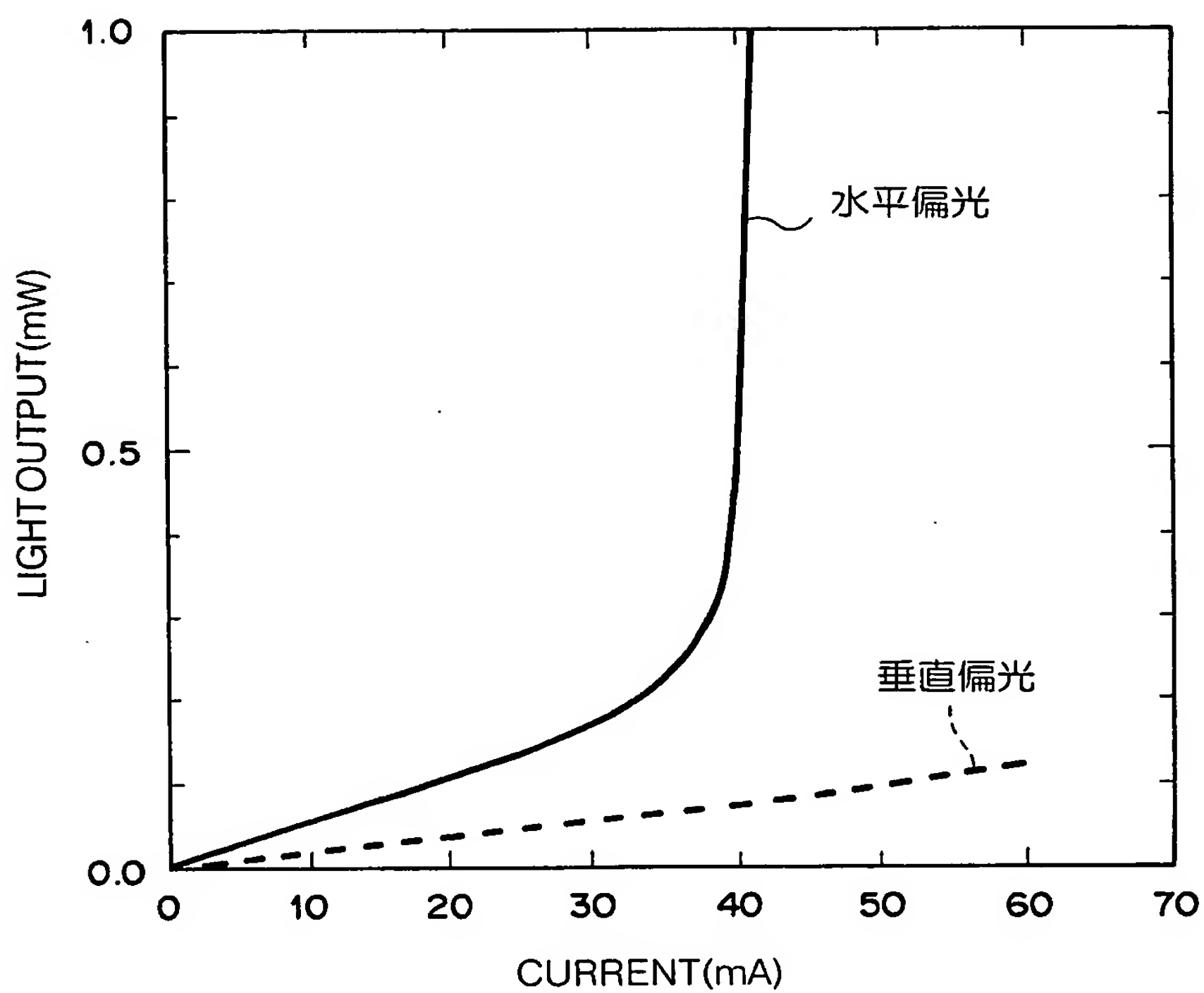
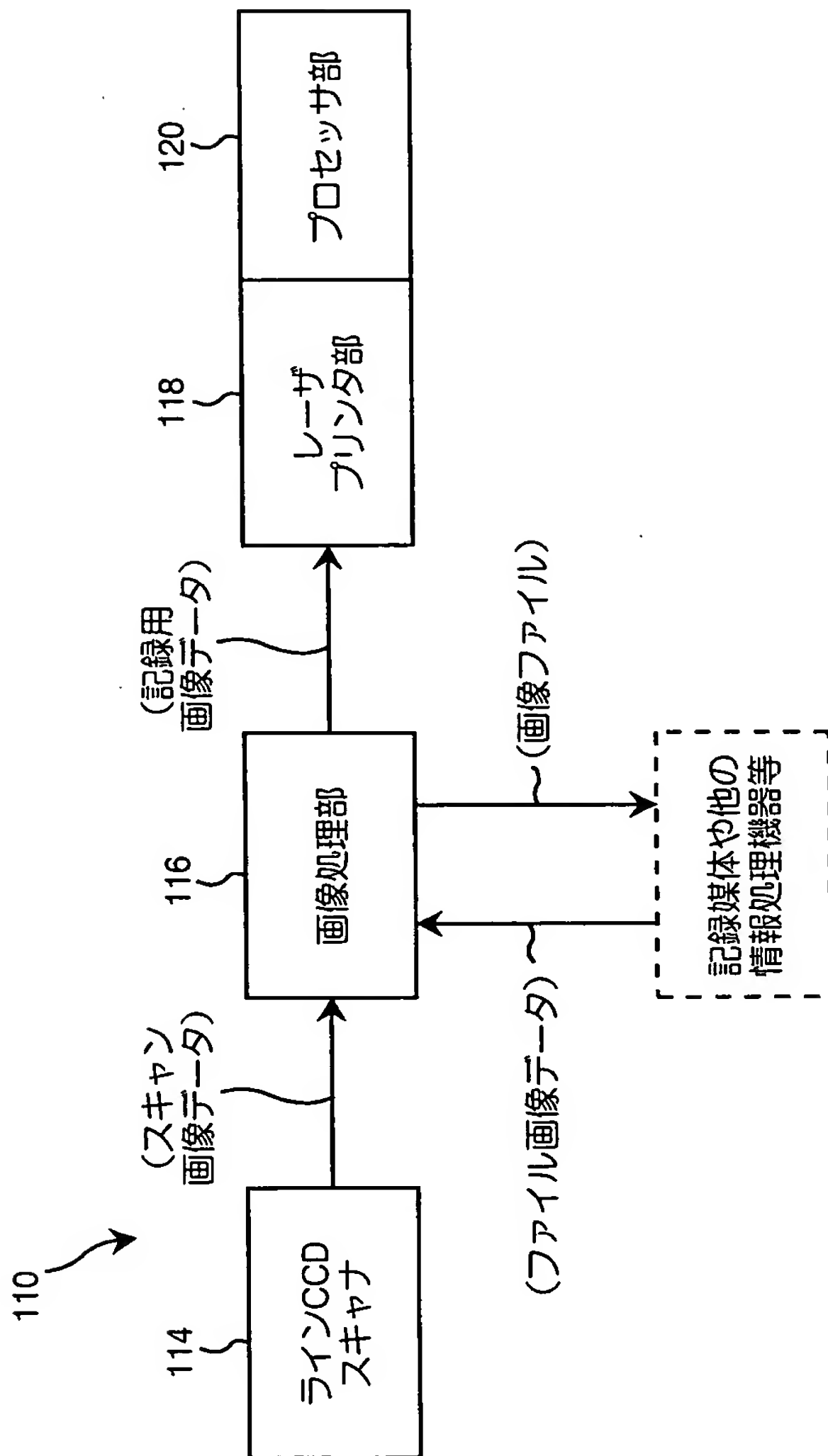
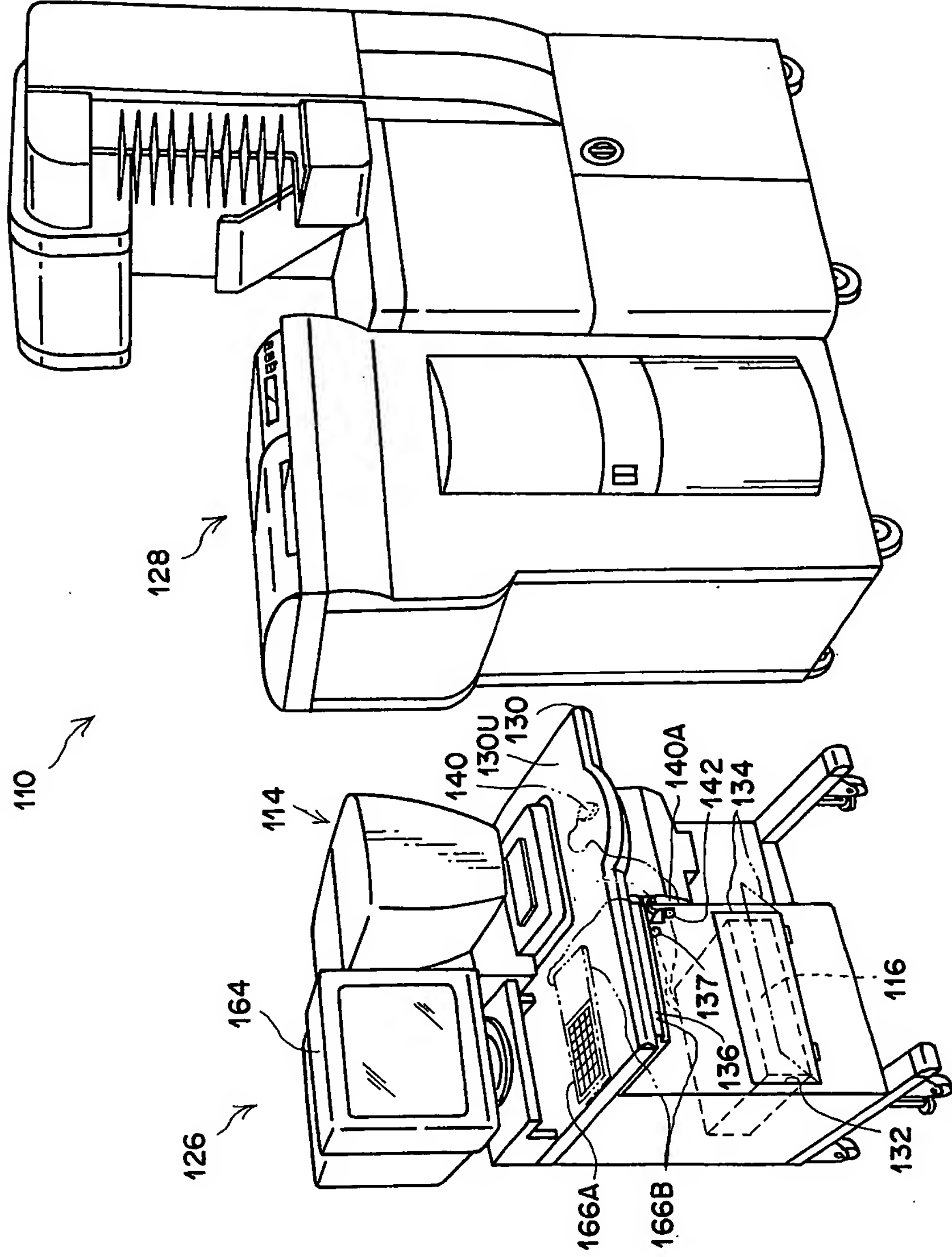


FIG.14



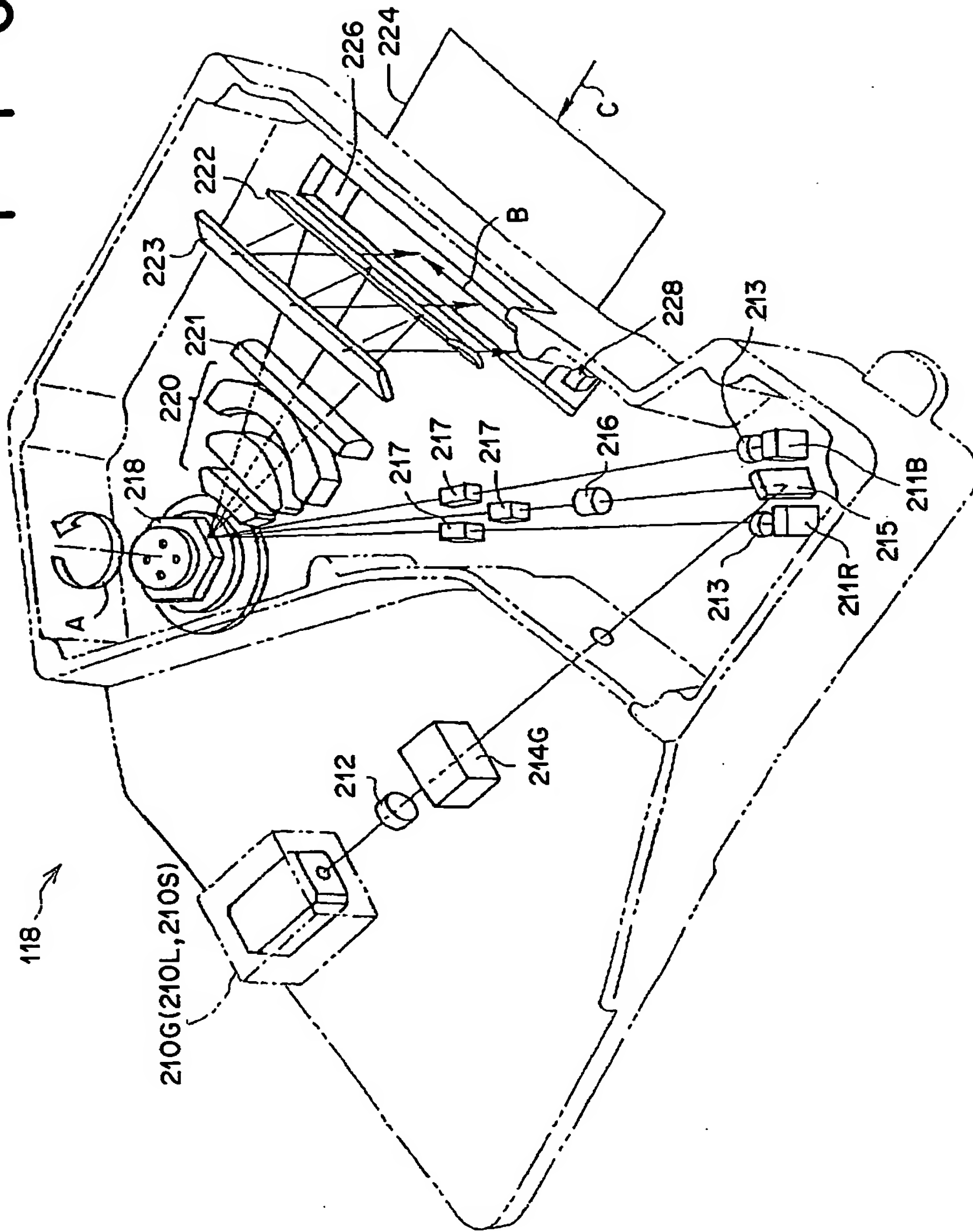
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F I G . 15



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A LIGHT SOURCE APPARATUS EQUIPPED WITH
A GaN TYPE SEMICONDUCTOR LASER,
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FIG. 16



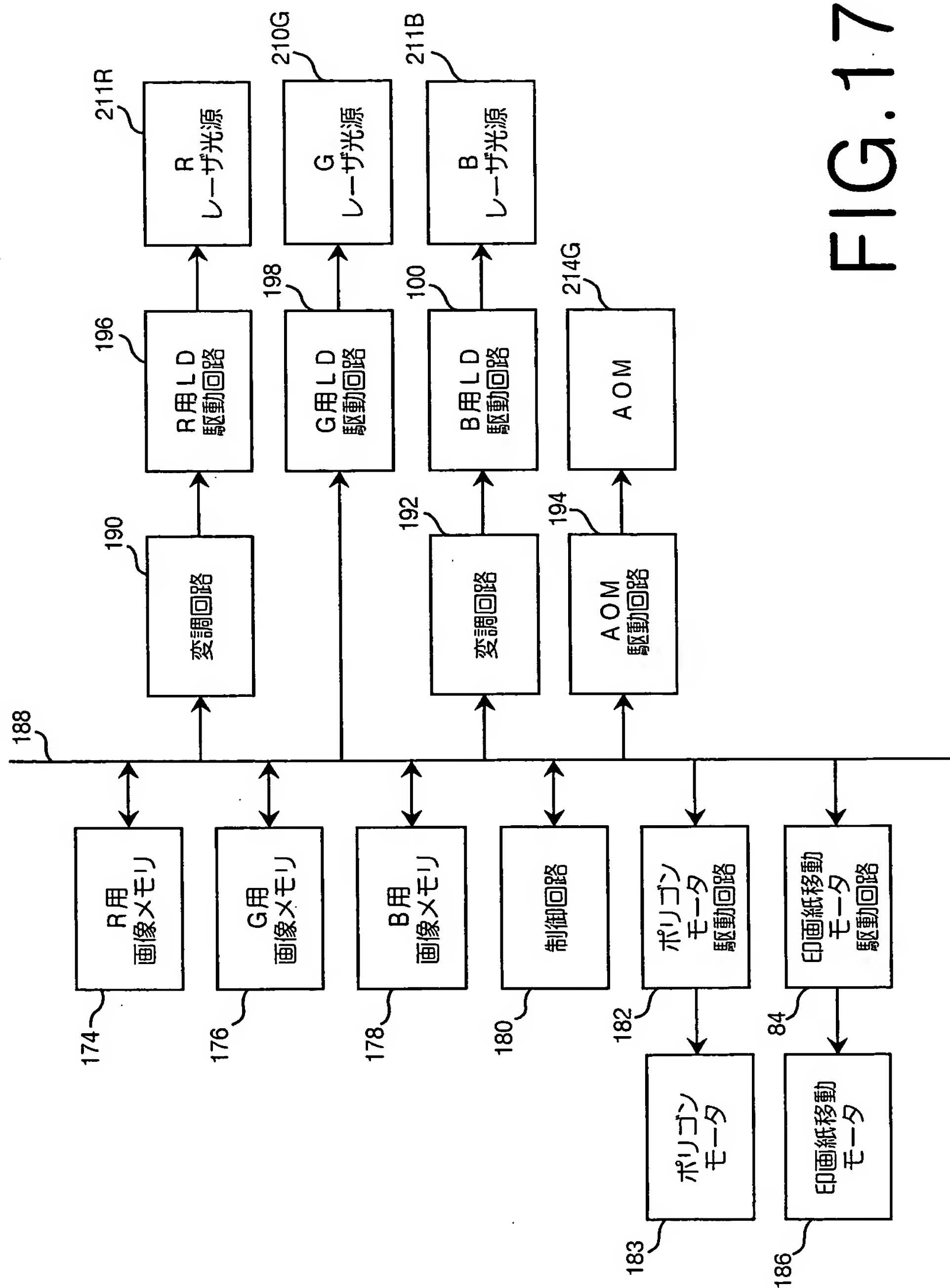


FIG. 17